Joint DESY and University of Hamburg Accelerator Physics Seminar

Simulation of Electron-Cloud Heat Load for the Cold arcs of the LHC

Thanks to F. Zimmermann, G. Contreras, G. Iadarola and S. Roubatel

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Outline

- Introduction:
 - What an electron cloud is?
 - Electron cloud effects
- Electron Cloud Simulations
 - Simulation tools
 - Methodology
- Results
 - What information can we obtain from the simulations?
 - What is the utility of such information?





The electron cloud (EC) is a set of electrons produced inside the beam pipe of a particle accelerator that reduce the quality of the beam or can have bad effects on the machine performance.

What are the seeds of the electron cloud?

- ➢ Residual gas ionization.
- Photoemission when the beam-induced synchrotron radiation hits the surface of the beam pipe.





Schematic of the EC build-up

How is produced the EC build-up?



Key elements:

Seed electrons (either residual gas ionization or photoemission).

Secondary emission process

Multipacting





What is the problem?

Electron cloud effects:

Due to e- induced gas desorption from the walls of the beam screen the vacuum pressure is increased by several orders of magnitude.

The electrons near the center of the vacuum chamber are attracted by the electric field of the beam and accumulate ("pinch") inside the proton beam during a bunch passage. They can cause beam instabilities, emittance growth, even beam loss, and poor lifetime.

The energetic electrons heat the surfaces that they impact. Only a limited cooling capacity is available for the additional heat load due to the electron cloud.





 \succ In 1999, EC effects have been observed with LHC-type beams first in the SPS, then in the PS.

Since 2010, as predicted, EC effects were observed in the LHC: pressure rise, cryogenic heat load, beam instabilities, beam loss and emittance growth.



F. Roncarolo





- ➤A sawtooth pattern on the horizontally outer side of the beam screen inside the cold arcs.
- ➤A shield mounted on top of the LHC beam-screen pumping slots blocking the electrons.
- \succ NEG coating.
- The ultimate mitigation technique:
 <u>Beam Scrubbing</u>

Reduction of the secondary emission yield with increasing electron dose hitting the surface, i.e., as a result of the EC itself.





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Simulation Codes:

- ECLOUD (F. Zimmermann et al.)
- PyECLOUD (G. ladarola)

Input numbers:

- Machine parameters
- Beam parameters
- Surface properties
- The EC simulation includes the electric field of the beam, arbitrary magnetic fields, the electron space charge field, and image charges.







Low-energy electron reflectivity (R):

it designates the probability for an elastic reflection of an electron hitting the wall in the limit of zero primary energy.





1. Seed electrons generation (gas ionization, photoemission)



Slides taken from G. ladarola ECLOUD meeting presentation on 28th November 2011



Ingredients for e-cloud build-up simulation

2. Force exerted by the beam on e⁻



Slides taken from G. ladarola ECLOUD meeting presentation on 28 – Nov - 2001









Gas ionization movie sample

Photoemission movie sample







Parameter	450 GeV	3.5 TeV	7 TeV
Bunch intensity	1.22x10 ¹¹ p/b	1.22x10 ¹¹ p/b	1.15x 10 ¹¹ p/b
RMS bunch length	11.8 cm	9 cm	7.55 cm
Bunch spacing	50 ns	50 ns	25 ns
Transverse normalized emittance	2 μm rad	2.5 μm rad	3.75 µm rad
Pressure	32 nTorr		

- All the simulations were performed for a bending section using ECLOUD version 4b.
- We assumed a Gaussian bunch profile.





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FRI





Heat load benchmarking:

ERI





Heat load contour plot for 25 ns bunch spacing at 450 GeV

FR









Nb



Evolution of δ max for the LHC arc chamber during the 2011 LHC run as inferred from benchmarking heat-load simulations (ECLOUD) and measurements at 25-ns and 50-ns bunch spacing, assuming a low-energy electron reflectivity <u>R = 0.5</u>.







- For the nominal LHC operation scheme with 25-ns bunch spacing at top energy, the maximum secondaryemission yield should be below 1.4 in order to reach the nominal bunch intensity with acceptable heat load.
- For the current operational mode of the LHC the calculations at 50-ns bunch spacing show acceptable heat load values for all combinations of δ_{max} and R.
- The simulated heat-load values can be compared with measured heat-load data for 50-ns and 25-ns bunch spacing in order to estimate the actual surface parameters (especially δ_{max}) for the LHC and their evolution in time.
- 0.5 < R < 0.7?





- Heat load benchmarking for the next scrubbing run at 25 ns.
- EC simulations for the HL-LHC.





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Thank you for your attention

Questions???

